			Docket Number (Optional)	Application Number
1 PINT	ORM.	ATION DISCLOSURE CITATION	FIS920030061US1 Applicant(s)	10/604,278
/0. 1	(C)	(Use several sheets if necessary)	Hariklia Deligianni, et al.	10
2 5 20	און און אמן אמן אמן אמן אמן אמן אמן אמן אמן אמ		Piling Date 7/8/03	Group Art Unit
E EXAMINER	J. S. F. F.	OTHER DOCUMENTS (Including Author, Title	le, Date, Pertinent Pages, Etc.)	·
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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.				